					<u> </u>	
Form PTO-144 (Rev. 8-83)		Department of Commerce ent and Trademark Office	Atty Docket 0756-2222	2	Serial No. 09/	(699,466
INFORMATION DISCLOSURE STATEMENT		Applicants: Shunpei YAMAZAKI et al.				
			Filing Date: October 3	1, 2000	Group Art U	nit: 2813
U.S. PATENT DOCUMENTS						
Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date (if appropriate)
AICS	3,389,024	06/18/1968	Schimmer			(ii appropriate)
AICS	4,472,458	09/18/1984	Sirinyan et al.			
AICS	4,481,121	11/06/1984	Barthel			
ALC	4,735,824	04/05/1988	Yamabe et al.		 	
AICS	4,911,781	03/27/1990	Fox et al.			
AIC	4,959,700	09/25/1990	Yamazaki			
AICS	4,996,523	02/26/1991	Bell et al.			
Alcs	5,089,441	02/18/1992	Moslehi			Ü
AICS	5,354,697	10/11/1994	Oostra et al.	1 1		
AICS	5,387,530	02/07/1995	Doyle et al.			
AICS	5,470,763	11/28/1995	Hamada	- \ \		
22FA	5,508,207	04/16/1996	Horai et al.			
AICS	5,530,266	06/25/1996	Yonehara et al.		\ /	
Alcs	5,543,636	08/06/1996	Yamazaki		\ /	
AK2	5,580,815	12/03/1996	Hsu et al.		1/2	
AICS	5,619,044	04/08/1997	Makita et al.		- CH	
Aics	5,661,311	08/26/1997	Takemura et al.		\\\\\\\\\\\\\\\\\\\\\\\\\\\\\\\\\\\\\\	 ਹ
AK2	5,684,317	11/04/1997	Hwang		信量	
Alcs	5,684,365	11/04/1997	Tang et al.	,	CE 30	1
A-KS	5,686,328	11/11/1997	Zhang et al.	,		<u> </u>
AICS	5,693,541	12/02/1997	Yamazaki et al.	 	70 10 0	j
AKS	5,693,959	12/02/1997	Inoue et al.	- 	2800	
Aics	5,696,003	12/09/1997	Makita et al.			<u></u>
Aics	5,717,224	02/10/1998	Zhang			
AKL	5,734,179	03/31/1998	Chang et al.			
22H	5,763,899	06/09/1998	Yamazaki et al.	- - - - - - - - - -		
AKS	5,782,665	07/21/1998	Weisfield et al.	- <i> </i> - - - - - - - - - -		
Acs	5,786,796	07/28/1998	Takayama et al.	- 		
AICS	5,821,560	10/13/1998	∦rai et al.			
AICS	5,828,429	10/27/1998	Takemura	- //		
1.102				<u></u>	1	
Examiner	Asoh human	Sardean	Date Considered	6/28	702	
*EXAMINER	: Initial if citation considered, wi	hether or not citation is	in conformance with MP	EP 609; Draw		tation if
not in conforn	nance and not considered. Includ	e copy of this formwith	next communication to a	applicant.		

Form PTO-1449 (Rev. 8-83)

U.S.Department of Commerce Patent and Trademark Office

Atty Docket 0756-2222

Serial No. 09/699,466

INFORMATION DISCLOSURE STATEMENT

Applicants: Shunpei YAMAZAKI et al.

Filing Date: October 31, 2000

Group Art Unit: 2813

U	J.S.	. PA	TENT	DOC	UMEN	NTS

xaminer nitial	Document Number	Date	Name	Class	Subclass	Filing Date (if appropriate
AICS	5,838,508	11/17/1998	Sugawara	1		appropriate
AICS	5,843,225	12/01/1998	Takayama et al.	1\		
AICS	5,846,857	12/08/1998	Ju	_ \ -		
Alcs	5,849,611	12/15/1998	Yamazaki et al.			
AKS	5,882,960	03/16/1999	Zhang et al.	+		
ACS	5,888,858	03/30/1999	Yamazaki et al.			
AICS	5,895,933	04/20/1999	Zhang et al.		- -	
AICL	5,899,547	05/04/1999	Yamazaki et al.			
AICS	5,922,125	07/13/1999	Zhang			
ALCS	5,929,464	07/27/1999	Yamazaki et al.	- - \		
AICO	5,933,205	08/03/1999	Yamazaki et al.	- -\	- 	
221A	5,940,732	08/17/1999	Zhang			
AICI	5,953,597	09/14/1999	Kusumoto et al.		\ /	
AICS	5,962,869	10/05/1999	Yamazaki et al.		\/	<u></u>
AICL	5,963,278	10/05/1999	Yamazaki et al.		\	
AICS	5,985,740	11/16/1999	Yamazaki et al.		\wedge	
AICI	5,990,491	11/23/1999	Zhang		/ \	
AICS	5,990,542	11/23/1999	Yamazaki	 	/ 	
Aics	6,005,648	12/21/1999	Zhang et al.	 	- - 	
Aicc	6,011,277	01/04/2000	Yamazaki	 	-	
Alcs	6,013,929	01/11/2000	Ohtani	 		
AICI	6,048,758	04/11/2000	Yamazaki et al.	- / 		
AIC2	6,063,654	05/16/2000	Ohtani	- 		
AICS	6,077,731	06/20/2000	Yamazaki et al.	- -/- 		
AIC?	6,083,801	07/04/2000	Ohtani	- 		
AICS	6,093,934	07/25/2000	Yamazaki et al.	 		
	6,100,562	08/08/2000	Yamazaki et al.			
AIC!	6,140,165	10/31/2000	Zhang et al.	- / 		
AKS AKS	6,147,667	11/14/2000	Yamazaki et al.			

Examiner A-5 The Muniar Sarlar Date Considered 6/28/02

^{*}EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this formwith next communication to applicant.

Form PTO-1449 **U.S.Department of Commerce** Atty Docket 0756-2222 (Rev. 8-83) Patent and Trademark Office INFORMATION DISCLOSURE STATEMENT Filing Date: October 31, 2000 **FOREIGN PATENT DOCUMENTS**

Serial No. 09/699,466

Applicants: Shunpei YAMAZAKI et al.

Group Art Unit: 2813

Examiner Initial	Document Number	Date	Country	Class	Subclass	<u>Translati</u> Yes	ion No
AICS	02-148687	06/07/1990	JP			Eng Abst	Τ
AICS	05-107561	04/30/1993	JP			Eng Abst	\dagger
	05 299348	11/12/1993	JP			Eng Abst	T
AICS	06-232059	08/19/1994	JP	$\overline{}$		Full Eng	T
V	07-161634	06/23/1995	JP			Eng Abst	t
ALCS	07-321339	12/08/1995	JP			Eng Abst	t
AICS	07-335900	12/22/1995	JP	- \		Eng Abst	十
AICS	08-129358	05/21/1996	JP		\ /	Eng Abst	T
ALCS	08-129359	05/21/1996	JP		\/	Eng Abst	T
AICS	08-129360	05/21/1996	JP		X	Eng Abst	T
AICS	08-234683	09/13/1996	JP	<u> </u>	/\	Eng Abst	t
AICS	08-241047	09/17/1996	JP		/ \	Eng Abst	T
AICS	08-241048	09/17/1996	JP		. 1	Eng Abst	T
AICS	08-241057	09/17/1996	JP	//		Eng Abst	T
AICS .	08-241997	09/17/1996	JP	- -/ 		Eng Abst	T
	61-063017	04/01/1996	JP	1/		Full Eng	‡
AICS	62-169356	07/25/1987	JP	1/		Eng Abst	T
22 HA	64-081324	03/27/1989	JP	1		Eng Abst	T

OTHER DOCUMENT

(Including Author, Title, Date, Pertinent Pages, Etc.)

_	
Examiner Initial	
AICS	Sze, M.S, "VLSI Technology", pp. 397-400, McGraw-Hill Publishing Company, Second Edition
Arcg	Dimitros et al., "Fluorine-Enhanced Oxidation of Polycrystalline Silicon and Application to Thin-Film Transistor Fabrication", pp. 937-937, August 24, 1992, Appl. Phys. Lett. 61 (8)
ACS	Baker et al., "Field Effect Transistor", pp. 849, December 1968, IBM Technical Disclosure Bulletin, Vol. 11, No. 7
AKS	Hayashi et al., "Fabrication of Low-Temperature Bottom-Gate Poly-Si TFTs on Large-Area Substrate by Linear-Beam Excimer Laser Crystallization and Ion Doping Method", pp. 829-832, 1995, IEEE 33.3.1, IEDM 95
AICS	Sakaguchi et al., "Current Progess in Epitaxial Layer Transfer (ELTRAN)", pp. 378-387, March 1997, IEICE Trans. Electron, Vol. E80, No. 3
AICS	Kuper et al., "Effects of Fluorine Implantation on the Kinetics of Dry Oxidation of Silicon", pp. 985-990, August 1, 1986, J. Appl. Phys. 60 (3)
AICS	Wolf et al., "Silicon Processing for the VLSI Era", pp. 198-207, 1965, Lattice Press, Vol. 1, Process Technology

Unmar Examiner willar Date Considered

*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this formwith next communication to applicant.

Form PTO-1449 (Rev. 8-83)		Department of Commerce atent and Trademark Office		Serial No. 09/699,466
INFORMATION DISCLOSURE STATEMENT		Applicants: Shunpei YAMAZAKI et al.		
			Filing Date: October 31, 2000	Group Art Unit: 2813
	ОТ	HER DOCUMENT	(Including Author, Title, Date, Pertinent Pa	iges, Etc.)
Examiner Initial				
Alcc	Kuo Y "Thin Film Transistor	Technologies" no 11	6-122 Vol. 94-35	



Examiner

ESTL UM

Sarhan

Date Considered

6 28 02

*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this formwith next communication to applicant.